



PATENT
97-CT-174

#21/EX
4/23/3
Sunder

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
RAFFAELE ZAMBRANO)
Serial No.: 09/191,743)
Filed: November 13, 1998)
For: IN-SITU DEPOSITION AND)
DOPING PROCESS FOR POLY-)
CRYSTALLINE SILICON LAYERS)
AND THE RESULTING DEVICE)

Group Art Unit: 2823

Examiner: M. Estrada

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with Rule 1.136, Applicant respectfully petitions the Commissioner for an extension of time extending to April 3, 2003, the period for response to the Office Action dated October 3, 2002. Please charge the amount of \$930.00 for the extension fee to Deposit Account No. 50-1556. The responsive paper is attached.


If it should be determined that a longer extension is required to prevent this application from becoming abandoned, or for any other reason an insufficient fee has been paid, please charge any insufficiency to Deposit Account No. 50-1556.

04/15/2003 MHQHAMMI 00000074 501556 09191743

01 FC:1253 930.00 CH

Date: April 3, 2003

Respectfully submitted,

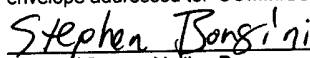
By: 
Stephen Bongini
Registration No. 40,917

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CERTIFICATE OF MAILING

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4/3/03
Date of Deposit